Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/749,670	KIM ET AL.	
Examiner	Art Unit	
Dennis Rosario	2624	

SEARCHED					
Class	Subclass	Date	Examiner		
332	144-150	5/17107	PR		

INTERFERENCE SEARCHED					
Subclass	Date	Examiner			
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	1				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East, all clB	5/17(07	DR		
IEEE-inspection (near) water and threshold #-	5/17/07	PR		
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